



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hidemasa KAI et al.**

Art Unit: 1792

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR  
STRUCTURE**

Attorney Docket Number: **030901**  
Customer Number: **38834**

**AMENDMENT UNDER 37 C.F.R. §1.116**  
**EXPEDITED PROCESSING REQUESTED**

**MAIL STOP AF**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

September 30, 2008

Sir:

In response to the Office Action dated June 12, 2008, for which the response date is extended by one month to October 12, 2008, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.

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